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Patent
Attorney's Docket No. 015290-238

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Jeffrey HUNG et al.) Group Art Unit: 1765
Application No.: 09/002,007) Examiner: L. Vinh
Filed: December 31, 1997)
For: ETCHING PROCESS FOR ORGANIC)
ANTI-REFLECTIVE COATING)

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REQUEST FOR INTERVIEW

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

The undersigned respectfully requests an interview with the Examiner in connection with the above application. The Examiner is requested to contact the undersigned at (703) 838-6560 in order to arrange such an interview.

Respectfully submitted,

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